

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/027,634	EDWARDS ET AL.	
Examiner	Art Unit	
Hong C Kim	2186	

	SEARCHED					
Class	Subclass	Date	Examiner			
707	20.6	4/26/05	Bh			
	205					
711	170					
	171					
	172					
	173					
	165					
	165 154	d				
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INT	INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner			
707	206 3	4/26/05	ide			
711	170		,			
	171,172	d				

SEARCH NOTES (INCLUDING SEARCH STRATEGY)					
	DATE	EXMR			
6431	4/26/08	- KL			
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